

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of) **MAIL STOP AMENDMENT**
Shigeyuki Akimoto et al.)
Application No.: 10/556,916) Group Art Unit: 2624
Filed: November 15, 2005) Examiner: Vanchy Jr., Michael J.
For: OUTER SURFACE-INSPECTING)
METHOD, MASTER PATTERNS) Confirmation No.: 1621
USED THEREFOR, AND OUTER)
SURFACE-INSPECTING)
APPARATUS EQUIPPED WITH)
SUCH A MASTER PATTERN)

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 30, 2009, please amend the above-identified patent application as follows: